

Tuesday Afternoon, October 30, 2012

Exhibitor Technology Spotlight

Room: West Hall - Session EW-TuA

Exhibitor Technology Spotlight

Moderator: D. Surman, Kratos Analytical Inc.

3:20pm **EW-TuA5 NEG Pumps Improving the Performance of Vacuum Systems**, *B. Garcia, E. Maccallini, P. Manini*, SAES Getters

The presentation will include a discussion of new and existing products and how NEG pump technology improves over all vacuum performance. The positive effect NEG Pump technology has on the bakeout process will be discussed as well. Examples and data will be provided to support the discussion.

3:40pm **EW-TuA6 New Developments in Thin Film Deposition from Kurt J. Lesker Company**[®], *S. Armstrong, D. Bingaman*, Kurt J. Lesker Company

In this spotlight the Kurt J. Lesker Company will update the industry on some of its new thin film deposition solutions.

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